

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yoshinobu KIMURA, et al.
Serial No.: 10/019,407
Filed: March 25, 2002
For: POLYCRYSTALLINE SEMICONDUCTOR THIN FILM
SUBSTRATE, MANUFACTURING METHOD OF THE
SAME, SEMICONDUCTOR DEVICE AND ELECTRONIC
DEVICE
Group: 2813
Examiner: Laura M. MENZ

PETITION FOR EXTENSION OF TIME

Mail Stop: EOT/Amendment
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 11, 2008

Sir:

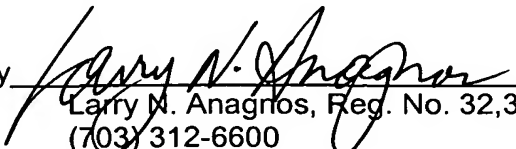
In the matter of the above-identified application, Applicants hereby respectfully petition for a five-month extension of time to permit filing a Request for Continued Examination (RCE), which is further to the filing of the Notice of Appeal on February 11, 2008, which was responsive to the period set with the mailing of the Final Office Action, dated September 10, 2007. A credit card authorization in the amount of \$2,230.00 to cover the required fee for the requested extension of time fee is also submitted.

It is respectfully requested that any shortage in the fees be charged to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (Docket No. 520.41003X00) and any excess fees credited to that account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

By


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